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Applicants: Mitsuhiro SHIKIDA et al.  
International Application No.: PCT/JP2005/000633  
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For: CHEMICAL ANALYTIC APPARATUS AND  
CHEMICAL ANALYTIC METHOD

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Sir:

Pursuant to 35 U.S.C. 119, this application is entitled to a claim of priority to Application No. 2004-8415 filed in Japan on January 15, 2004.

Respectfully submitted,

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